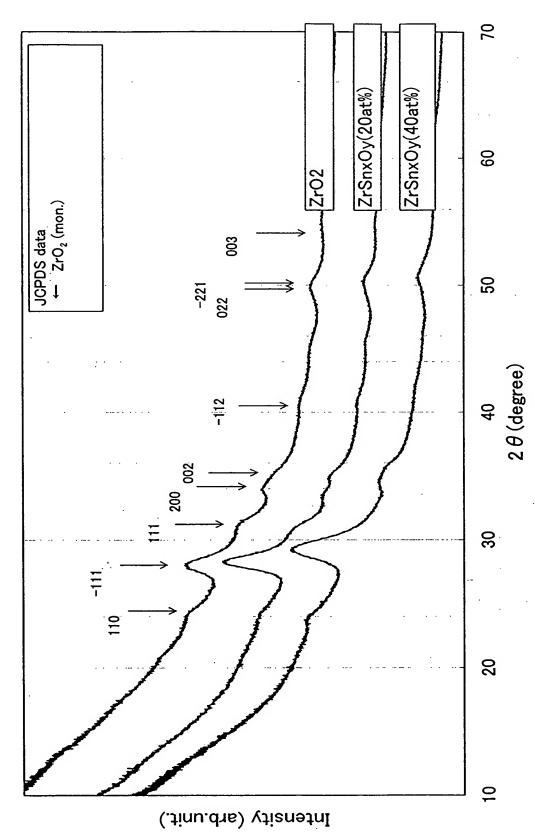
MAR 2 6 2004 W

XRD pattern of ZrO₂ and ZrSnxOy [Film composition SiO_2 (10nm) / ZrO₂ (150nm)]



XRD pattern of TiO $_{\rm 2}$ laminated on ZrO $_{\rm 2}$ and ZrSnxOy [Film composition SiO $_{\rm 2}$ (10nm) / ZrO $_{\rm 2}$ (25nm) / TiO $_{\rm 2}$ (150nm)]

